Amendments to the Specification:

Please replace paragraphs [0067] to [0068] with the following rewritten paragraphs:

[0067] FIG. 15 shows an example of electronic equipment including the semiconductor integrated circuit according to an exemplary embodiment of the invention; and

[0068] FIG. 16 shows a related art device to monitor the amount of light emitted from a surface-emitting-laser, laser; and

Page 10, after paragraph [0068], insert new paragraph [0068.1] as follows:

[0068.1] FIG. 17 is a sectional view schematically showing a semiconductor integrated circuit according to an exemplary embodiment of the invention.

Please replace paragraph [0081] with the following rewritten paragraph:

[0081] Here, As shown in FIG. 17, a diffraction grating 11a may replace the lens 11 on the transparent substrate 10. The diffraction grating 11a converges or diverges the front light L1. By having the diffraction grating 11a shaped in an intended formation, it is possible to change a path of the front light L1 and split the front light L1. Therefore, by using the diffraction grating 11a instead of the lens 11, it is possible to easily manufacture various electronic equipment utilizing laser light that are compact in shape.

Please replace paragraph [0101] with the following rewritten paragraph:

[0001] n-In another step (not shown), the micro tile-like element 161 is firmly adhered to the final substrate 171, for example, by a heating process.